



IPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasutsugu SOETA

Group Art Unit: 3723

Application No.: 10/573,497

Examiner: D. NGUYEN

Filed: March 27, 2006

Docket No.: 127462

For: POLISHING PAD, METHOD FOR PROCESSING POLISHING PAD, AND METHOD  
FOR PRODUCING SUBSTRATE USING IT

**SUMMARY OF SUBSTANCE OF PERSONAL INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

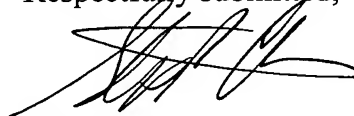
Sir:

Applicant appreciates the courtesies shown to Applicant's representative by Examiner  
Nguyen in the March 6 personal interview. Applicant's separate record of the substance of  
the interview is incorporated into the following remarks.

The claim amendments and arguments set forth in Applicant's March 3, 2009  
Amendment were discussed.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



William P. Berridge  
Registration No. 30,024

Stephen P. Catlin  
Registration No. 36,101

WPB:SPC/add

Date: March 13, 2009

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**P.O. Box 19928**  
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